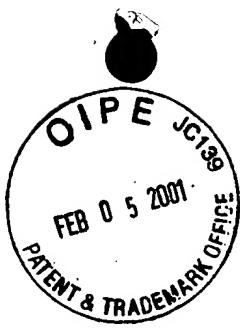


35.C14386



PATENT APPLICATION

#6  
C. Barnes  
5-2-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE **RECEIVED**

In re Application of: ) FEB 09 2001  
SEIJI MISHIMA ) : Examiner: NYA  
Application No.: 09/694,268 ) : TO 3600 MAIL ROOM  
Filed: October 24, 2000 ) : Group Art Unit: 3661  
For: METHOD OF MANUFACTURING ) :  
ELECTRONIC DEVICE, ) :  
ELECTRON SOURCE ) :  
SUBSTRATE, AND IMAGE ) :  
FORMING APPARATUS, AND ) :  
APPARATUS FOR ) :  
MANUFACTURING ELECTRONIC ) :  
DEVICE AND ELECTRON ) :  
SOURCE SUBSTRATE ) February 2, 2001

Commissioner for Patents  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

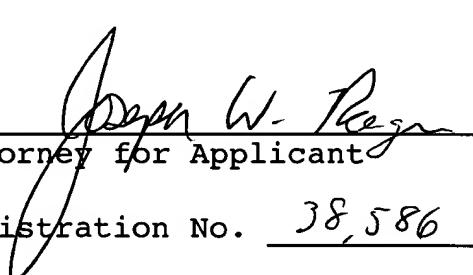
In compliance with the duty of disclosure under  
37 C.F.R. § 1.56 and in accordance with the practice under  
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is  
directed to the documents listed on the enclosed Form PTO-  
1449. Copies of the listed documents are also enclosed.

For the concise statement of relevance for the non-English documents, the Examiner is respectfully referred to the English Abstracts attached thereto.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicant

Registration No. 38,586

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30 Rockefeller Plaza  
New York, New York 10112-3801  
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